



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Smith, et al. Docket No: TI-25250
Serial No: 09/199,829 Conf. No: 4119
Examiner: Julio Maldonado Art Unit: 2823
Filed: 11/25/98
For: HYDROGEN PLASMA PHOTORESIST STRIP AND POLYMERIC RESIDUE
CLEANUP PROCESS FOR OXYGEN-SENSITIVE MATERIALS

AF
\$2800
19/ Oral
hearing
P. Walker
2-21-03

REQUEST FOR ORAL HEARING

Assistant Commissioner For Patents
Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)

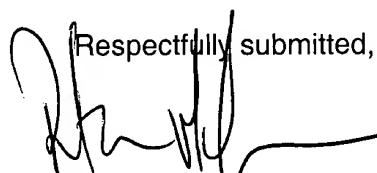
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on 1-24-03.

Ann Trent
Ann Trent

Dear Sir:

Applicants respectfully request that an Oral Hearing be scheduled on the above identified application. Please charge the \$280.00 fee to the deposit account of Texas Instruments Incorporated, Account 20-0668. **This form is submitted in triplicate.**

02/13/2003 NGBREM1 00000099 200668 09199829
01 FC:1403 280.00 CH

Respectfully submitted,

Peter K. McLarty
Attorney for Applicants
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